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PATENT



Practitioner's Docket No. DN 01-016

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Hockman, John Albert

Application No.: 09/878,642

Group No.: 1731

Filed: 06/11/2001

Examiner: Not assigned

For: Method of Reducing the Boron Required in a Glass Batch

Assistant Commissioner for Patents
Washington, D.C. 20231

Attention: Vicky Beach
Petition Director

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CONFIRMATION OF INFORMATION AS TO STATUS OF AN APPLICATION

1. Information was requested by telephone on December 6, 2001 at approximately 10:30 a.m. as to the status of the "Petition to Make Special" filed on July 16, 2001 for the above-identified application number 09/878,642.
2. Bessie Bowie, Customer Service for Patent Examination Status, reviewed the referenced file to find the Petition to Make Special in the file unattended to.
3. Ms. Bowie proceeded to assure me that the Petition to Make Special would be immediately forwarded to the Director in the appropriate Petition Division for review and that we may expect a response within the next few weeks.
4. Please make this correspondence part of the official record of this application.

Date: December 7, 2001

Reg. No. 29,840

Tel. No.: (610) 861-3466


SIGNATURE OF PRACTITIONER

Marvin J. Powell

1 Highland Avenue
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Practitioner's Docket No. DN 01-016

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re application of: Hockman, John Albert

Application No.: 09/878,642

Group No.: 1731

Filed: June 11, 2001

Examiner: Not yet assigned

For: METHOD OF REDUCING THE BORON REQUIRED IN A GLASS BATCH

Assistant Commissioner for Patents
Washington, D.C. 20231

CERTIFICATE OF MAILING


Date of Deposit: December 7, 2001

I hereby state that the following *attached* paper(s) or fee(s)

CONFIRMATION OF INFORMATION AS TO STATUS OF AN APPLICATION

are being deposited with the United States Postal Service under 37 CFR 1.10, on the date indicated above and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

Andrea I. Rennig



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